Information Disclusive Statement USSN 09/768,911 August 9, 2002 Page 3

Form PTO-1449 (Modified)	ATTY DOCKET NO. B-3962 618027-2	U.S SERIAL NO. 09/768,911		
LIST OF PATENTS AND PUBLICATIONS STATEMENT	APPLICANT(S) Lap-Wai CHOW, et al.			
	FILING DATE January 24, 2001	GROUP 2911282+		

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Information Disclosure Statement USSN 09/76 211
August 9, 200 PART 1

Page 4

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(A)	4,821,085	4/89	Haken et al.	357	67.			1/
M	4,830,974	5/89	Chang et al.	437	34		18 11	
(D)	4,939,567	7/90	Kenney	257	383			
l#	4,975,756	12/90	Haken et al.	357	4.1		\exists	J
1116	4,998,151	3/91	Korman et al.	257	328		\exists	•
100	4,962,484	10/90	Takeshima et al. /	365	226		1	
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THE.	5,308,682	5/94	Morikawa	428	195			
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Information sisclosu USSN 09/768,9 Statement August 9, 2002 Page 7

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